235/1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	r ' rr st			
Ryuichi EBINUMA et al.	Examiner: H. Nguyen Croup Art Unit: 2851			
Application No.: 09/817,018	: Group Art Unit: 2851			
Filed: March 27, 2001)			
For: SUPPORTING STRUCTURE OF OPTICAL ELEMENT, EXPOSURE APPARATUS HAVING THE SAME, AND MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE) May 8, 2003 :)			

Commissioner for Patents Washington, D.C. 20231

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on June 21, 2001, and the Supplemental Information Disclosure Statement filed on April 24, 2003, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form. A copy of the listed document is also enclosed.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is authorized to charge Deposit Account No. 06-1205 should any other fees be deemed necessary in connection with this paper.

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RECEIVE

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants Steven E. Warner

Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200

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FORM PTO 1449 (modified)			ATTY DOCKET NO. 03560.002758 APPLICATION NO. 09/817,018							
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S)			APPLICANT Ryuichi EBINUMA et al.							
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) May 8, 2003			FILING DATE March 27, 2001			GROUP 2851				
U.S. PATENT DOCUMENTS										
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME CLASS		S SUBCLASS	FILING DATE			
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FOREIGN PATENT DOCUMENTS										
		DOCUMENT NUMBER	DATE		COUNTRY	CLAS	S SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT		
		11-149029	06/02/1999		Japan			Yes		
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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)										
OTTER SOCIETY (O) (Indicating Auditor, Title, State, Telement Lagos, Ede.)										
EXAMINER					DATE CONSIDERED					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.